Applicant(s)/Patent under Reexamination	Applicant(s)/Patent under Reexamination	
ADL-TABATABAI ET AL.	ADL-TABATABAI ET AL.	
Art Unit		
	Reexamination ADL-TABATABALET AL.	

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Chun-Kuan (Mike) Lee

SEARCHED						
Class	Subclass	Date	Examiner			
710	68	11/13/2007	CKL			
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INTERFERENCE SEARCHED					
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	DATE	EXMR
Updated EAST search:US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT Updated Inventor search utilizing eDan and EAST	11/13/2007	CKL
(710/68).ccls. limited text search	11/13/2007	CKL
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